



U.S. Patent Application No. 10/518,704
Response to Office Action mailed March 1, 2007

PATENT
930055-2031

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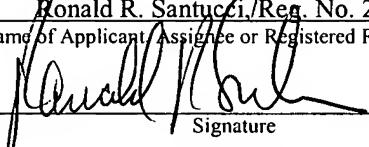
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Tetsuo YAMADA, et al.
Serial No. : 10/518,704
For : THIN FILM PIEZOELECTRIC RESONATOR, THIN FILM PIEZOELECTRIC DEVICE, AND MANUFACTURING METHOD THEREOF (As Amended)
Filing Date : December 17, 2004
Examiner : Mark Osborne Budd
Group Art Unit : 2834
Confirmation No. : 5674

745 Fifth Avenue
New York, NY 10151
(212) 588-0800

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on April 30, 2007.

Ronald R. Santucci, Reg. No. 28,988
(Name of Applicant, Assignee or Registered Representative)


Signature

April 30, 2007

Date of Signature

AMENDMENT UNDER 37 C.F.R. 121

AF
Mail Stop Amendment—
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated March 1, 2007, setting a three-month period for response ending June 1, 2007, Applicants respectfully request that the application be further amended as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 16 of this paper.